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THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of)
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MAEDA et al) Art Unit: 2829
)
Serial No.: 09/808,016) Examiner: Kilday
)
Filed: March 15, 2001)
)
For: FILM-FORMING SURFACE)
REFORMING METHOD AND)
SEMICONDUCTOR DEVICE)
MANUFACTURING METHOD)

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97©)

Commissioner for Patents
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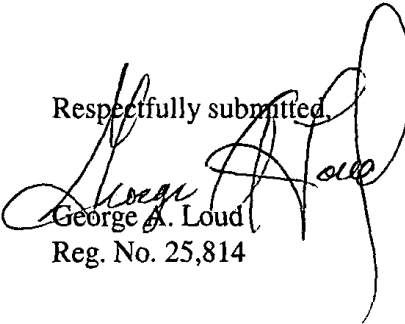
Sir:

Submitted herewith is a copy of an office action received from the Japanese Patent Office in connection with Japanese Application No. 2001-001759, together with a partial translation thereof. Also submitted herewith are copies of three Japanese Kokai Publications cited as document numbers 1, 2 and 5 in the Japanese office action of April 22, 2003 and listed on the attached PTO-A820. Also enclosed are published English language abstracts for each of the three Japanese Kokai Publications submitted here. The documents referred to in the Japanese office action of April 22, 2003 identified as document numbers 3 and 4 are already of record in the captioned application.

CERTIFICATION

The undersigned hereby certifies that each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three (3) months prior to the filing of this Information Disclosure Statement.

Respectfully submitted,



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Dated: July 9, 2003

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OSURE CITATION
(if necessary)
JUL 09 2003
PATENT & TRADEMARK OFFICE

ATTY DOCKET NO.
OKA-C062

SERIAL NO. 09/808,016

Kazuo MAEDA

FILING
15 MAR 01

GROUP	1	2	3	4	5	6	7	8	9	10	11	12	13	14	15	16	17	18	19	20	21	22	23	24	25	26	27	28	29	30	31	32	33	34	35	36	37	38	39	40	41	42	43	44	45	46	47	48	49	50	51	52	53	54	55	56	57	58	59	60	61	62	63	64	65	66	67	68	69	70	71	72	73	74	75	76	77	78	79	80	81	82	83	84	85	86	87	88	89	90	91	92	93	94	95	96	97	98	99	100
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U.S. PATENT DOCUMENTS

[illegible]

FOREIGN PATENT DOCUMENTS

[illegible]

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.